



In re application of : **Confirmation No. 4252**  
Yoichi MORI et al. : Docket No. 2000\_1578A  
Serial No. 09/714,220 : Group Art Unit 1764  
Filed November 17, 2000 : Examiner H. T. Tran

METHOD AND APPARATUS FOR TREATING  
A WASTE GAS CONTAINING FLUORINE-  
CONTAINING COMPOUNDS

RECEIVED  
MAR 04 2004

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of  
August 27, 2003.


The fee of \$950.00 is

(X) submitted herewith.  
( ) to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.

( ) Small entity status of this application is established by a Small Entity Status Assertion  
which  
( ) is enclosed.  
( ) has been previously submitted.

Respectfully submitted,

Yoichi MORI et al.

By   
Joseph M. Gorski  
Registration No. 46,500  
Attorney for Applicants

03/03/2004 HMEKONEN 00000076 09714220

01 FC:1253 950.00 OP

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February 27, 2004